



EXPRESS MAIL NO. EV530952750US

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE - EXAMINING GROUP 2810**

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Pietro Erratico et al.
Application No. : 10/712,211
Filed : November 12, 2003
For : **PROCESS FOR FORMING A BURIED CAVITY IN A
SEMICONDUCTOR MATERIAL WAFER AND A BURIED
CAVITY**

Patres. and Mail
BOX AF

Examiner : George C. Eckert II
Art Unit : 2815
Docket No. : 854063.618D1
Date : July 26, 2005

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE/AMENDMENT UNDER 37 CFR 1.116

Commissioner for Patents:

In response to the Office Action dated April 26, 2005, please amend the application as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.

*OKAY TO ENTER AMENDMENT,
QW 8/5/05*